# Photoluminescence up-conversion at $GaAs/InGaP_2$ interfaces driven by a sequential two-photon absorption mechanism

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This paper reports on the results of an investigation into the nature of photoluminescence up-conversion at GaAs/InGaP<sub>2</sub> interfaces. Using a dual beam excitation experiment, we demonstrate that the up-conversion in our sample proceeds via a sequential two-photon optical absorption mechanism. Measurements of photoluminescence and up-conversion photoluminescence revealed evidence of the spatial localisation of carriers in the InGaP<sub>2</sub> material, arising from partial ordering of the InGaP2. We also observed the excitation of a 2-dimensional electron gas at the GaAs/InGaP<sub>2</sub> heterojunction that manifests as a high-energy shoulder in the GaAs results spectrum. Furthermore, photoluminescence the of up-conversion photoluminescence excitation spectroscopy demonstrate that the photon energy onset of up-conversion luminescence coincides with the energy of the 2-dimensional electron gas at the GaAs/InGaP<sub>2</sub> interface, suggesting that charge accumulation at the interface can play a crucial role in the up-conversion process.

#### I. INTRODUCTION

Photoluminescence (PL) up-conversion, the emission of a high-energy photon following the absorption of two or more lower energy photons, has long been known to occur at the interfaces between III-V semiconductors.<sup>1–12</sup> Although it has been observed in a variety of materials, considerable work has been devoted to investigating the phenomenon at the interface of GaAs and  $InGaP_2$  layers.<sup>1–3,5,10,11</sup> Nevertheless there is no general consensus in the literature regarding the mechanism by which the up-conversion process occurs. Early reports from Driessen *et al.*<sup>1,2</sup> suggested that a cold Auger process was responsible for the up-conversion photoluminescence (UPL) signal in their samples. This claim was supported by a collinear beam photoluminescence excitation (PLE) spectroscopy experiment, in which the authors observed a step in the two-beam luminescence signal when the excitation energy was tuned through the GaAs band edge. This was interpreted as an indication that both beams contributed to up-conversion only by excitation of carriers in the GaAs, thereby increasing the carrier population available to the Auger process (the rate of which was a non-linear function of carrier density). Meanwhile, other groups working on up-conversion in similar GaAs/InGaP<sub>2</sub> samples suggested that the mechanism responsible was a two-step (i.e. sequential) absorption process. This assertion was supported by measurements of the up-conversion signal when the excitation energy was below that of the GaAs exciton;<sup>10</sup> by pressure and magnetic field dependent measurements of the up-conversion luminescence;<sup>11</sup> and using time-resolved photoluminescence to study the rate of decay of the up-converted PL.<sup>3,5</sup> While there has been no general agreement on the up-conversion mechanism there has similarly been a variety of reports in the literature of the effect of growth and structural parameters on the up-converted luminescence;<sup>2,10,11,13</sup> perhaps indicating a level of interdependency that leads to variation in the nature of the up-conversion between different samples.

Interest in the phenomenon of photoluminescence up-conversion has recently been reignited,<sup>7,8</sup> in part owing to the recognition of its potential to improve the efficiency of solar cells, either directly<sup>14</sup> or as an internal process within an intermediate band solar cell.<sup>15</sup> However, to usefully take advantage of an up-converting layer such as the GaAs/InGaP<sub>2</sub> interface, it is necessary to reliably determine the mechanism by which the up-conversion proceeds.

Herein we therefore present a spectroscopic analysis of up-conversion observed in an  $InGaP_2$  p-i-n solar cell grown on a GaAs substrate. In this work we focus purely on optical spectroscopy of the up-converted luminescence to shed light on the mechanism involved, while Barnham *et al.*<sup>16</sup> previously reported the electrical properties of the solar cell under normal operation. By using a dual beam excitation experiment we demonstrate that the up-conversion in our sample proceeds via a sequential two-photon absorption mechanism.

### **II. EXPERIMENTAL**

The  $InGaP_2$  p-i-n structure, known as sample M810, was grown on an n-type (001) GaAs substrate by molecular beam epitaxy (MBE) at the University of Sheffield. First a 250 nm n-GaAs buffer layer was grown, upon which 300 nm of n-type  $InGaP_2$  was deposited;

the doping density for both layers was  $2x10^{18}$  cm<sup>-3</sup>. A 950nm thick layer of nominally undoped InGaP<sub>2</sub> was grown next; followed by 150 nm of p-type InGaP<sub>2</sub> with a doping density of  $1x10^{18}$  cm<sup>-3</sup>. MBE grown InGaP<sub>2</sub> such as this typically exhibits weak partial ordering.<sup>17,18</sup> Finally a 10 nm capping layer of p-GaAs with a doping density of  $2x10^{18}$  cm<sup>-3</sup> was deposited.

To enable a better understanding of the optoelectronic processes in sample M810 we performed a calculation of the electronic structure of the sample using the wellestablished Poisson-Schrodinger solver Nextnano3.<sup>19</sup> Presented in Fig. 1(a) are the calculated conduction and valence band edges from the sample surface to the substrate. There are two GaAs/InGaP<sub>2</sub> interfaces where up-conversion may occur and of particular interest is the alignment at these interfaces. The top surface of the sample is to the left of the diagram at 0 nm and shows the first, or front, interface where the 10 nm p-GaAs cap meets the p-type InGaP<sub>2</sub> material. At a depth of 1410 nm in the sample, in the n-type region, is the second, or rear, GaAs/InGaP<sub>2</sub> interface at the buffer layer. Due to the doping levels in the two interface regions of the sample, the conduction and valence bands are pinned such that while we expect a type I interface, the valence band (conduction band) provides the majority of the band offset in the n-type (p-type) material.

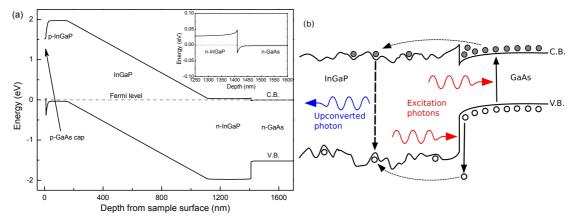


FIG. 1: (a) Band edge diagram of M810 calculated using Nextnano3.<sup>19</sup> 0 nm on the abscissa represents the top surface of the sample. A magnified representation of the band bending in the conduction band at the n-type GaAs/InGaP<sub>2</sub> interface is shown in the inset. The conduction and valence bands are labelled with C.B. and V.B. respectively. (b) Schematic showing the spatial localisation of carriers in the InGaP<sub>2</sub> due to alloy ordering, as well as how up-conversion can proceed via sequential two-photon absorption at the rear interface.

The Nextnano3 results also depict band bending at both of the  $GaAs/InGaP_2$  interfaces where the band offsets are pinned by the Fermi level. In particular the inset of Fig. 1(a) shows in detail the bending in the conduction band in the n-type region. However, it is important to note at this stage that Nextnano3 does not account for any residual CuPt ordering of the InGaP<sub>2</sub> material, which is known to occur in samples grown under similar conditions.<sup>17,18</sup> It has been shown that partial CuPt ordering of the InGaP<sub>2</sub> gives rise to polarisation fields and hence sheet charge at the interfaces with the GaAs, which we expect to further exaggerate the band bending observed at the interfaces.<sup>20–22</sup> This is important because the triangular potential that arises due to this band bending has been reported to lead to the formation of a 2-dimensional electron gas (2DEG) close to the interface.<sup>21,22</sup> This will be discussed in more detail later.

The partial CuPt ordering also acts to reduce the band gap of the  $InGaP_2$  compared to fully disordered material and introduces spatially localised states due to local variations in the alloy ordering (and hence the band gap). This is depicted in Fig. 1(b) in which a schematic of the rear interface is presented. The diagram also shows how photoluminescence up-conversion can proceed via sequential two-photon absorption at the rear interface.

Spectroscopic measurements were performed in a closed-cycle helium cryostat at a temperature of 10-20 K, using a variety of excitation sources appropriate to the measurements. Photoluminescence was excited using a pulsed PicoQuant laser diode emitting at 2.583 eV and operated at a repetition rate of 80 MHz. Meanwhile, the excitation source used for detailed measurements of the photoluminescence spectrum from the GaAs layers was a Spectra-Physics tuneable, continuous wave (CW) Ti:sapphire laser, pumped by a solid state Millennia V. The luminescence was dispersed by a 0.5 m spectrometer and detected using either a Si photodiode or a cooled GaAs photomultiplier tube using standard lock-in techniques.

In the cases of the up-conversion photoluminescence, as well as the photoluminescence excitation spectroscopy and up-conversion excitation spectroscopy the excitation source was again the Ti:sapphire laser, operated in the range 1.459-1.771 eV. Here we additionally used appropriate optical filters to reject stray light and separate sample luminescence from the excitation source. Finally, for the dual-beam photoluminescence and excitation spectroscopy we used a CW diode laser emitting at 1.699 eV in conjunction with the Ti:sapphire, which was tuned from 1.240-1.771 eV. Once again appropriate filtering of the excitation and emission beams was employed.

Note that the pulsed laser diode was used only for the high photon energy excitation source in photoluminescence measurements of the InGaP<sub>2</sub>. All of the up-conversion spectroscopy was performed using CW excitation.

## **III. RESULTS & DISCUSSION**

### A. Photoluminescence spectroscopy

To determine the overall emission profile from the sample, PL spectra were measured at different excitation powers. Shown in Fig. 2(a) are low temperature photoluminescence spectra of sample M810, excited above the InGaP<sub>2</sub> band edge at a photon energy of 2.583 eV and at two different time-averaged power densities. At the higher power density of 5.5 Wcm<sup>-2</sup> (black curve) we observe a strong PL peak from the InGaP<sub>2</sub> at 1.955 eV, as well as a weak, low energy tail extending to 1.90 eV. An additional peak arising from recombination in the GaAs can be seen close to 1.556 eV. At the lower power density (red dashed curve, 6.7 mWcm<sup>-2</sup>) the GaAs PL peak remains visible, whereas the InGaP<sub>2</sub> luminescence can be characterised by two strong, distinct peaks. The peak at 1.955 eV remains present but the intensity is lower by a factor of around 3000, revealing PL from the low energy shoulder at 1.920 eV as well as a third peak emerging at 1.873 eV. Additionally we observe an extended low energy tail to the InGaP<sub>2</sub> peak at this low excitation power density, with weak luminescence detected until the onset of the GaAs peak.

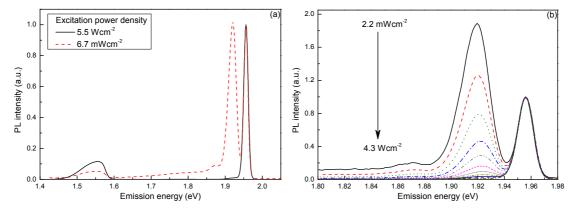


FIG. 2: (a) Photoluminescence spectra of sample M810 measured at low temperature with excitation power densities of 5.5 Wcm<sup>-2</sup> (black curve) and 6.7 mWcm<sup>-2</sup> (red dashed curve). (b) InGaP<sub>2</sub> luminescence measured as a function of excitation power density. The spectra are normalised to the intensity of the high energy (1.955 eV) InGaP<sub>2</sub> luminescence.

That the low-energy features in the  $InGaP_2$  photoluminescence spectra in Fig. 2(a) are observed only at low power density is indicative of a low density of states. This

observation was confirmed by measurements of the  $InGaP_2$  PL as a function of excitation power density from 2.2 mWcm<sup>-2</sup> to 4.3 Wcm<sup>-2</sup>. The resulting spectra are shown in Fig. 2(b) normalised to the intensity of the high-energy  $InGaP_2$  peak. At the lowest power density the peak at 1.920 eV dominates the spectrum, being more intense than the high-energy  $InGaP_2$  peak by a factor of 1.9. As the power density is increased however, this low-energy  $InGaP_2$  peak quenches with respect to the peak at 1.955 eV until it is visible only as a weak tail to the PL at the highest power density. We ascribe these observations to the presence of spatially localised states in the  $InGaP_2$  material that give rise to the low energy features and become saturated at high excitation power densities. In contrast, the high-energy  $InGaP_2$  peak in Fig. 2 corresponds to delocalised band-to-band recombination. Further evidence of localisation in the  $InGaP_2$  was found in the form of characteristic non-exponential photoluminescence decay curves (not shown here) measured using time correlated single photon counting.

This type of spatial localisation may be crucial to the up-conversion in that it can act as a trap for up-converted carriers and slow their relaxation back into the GaAs, as depicted schematically in Fig. 1b. We also note at this stage that the presence of two peaks in the photoluminescence spectra and evidence for a spread of localised tail states in the InGaP<sub>2</sub> are commonly reported for partially ordered material.<sup>23–28</sup> Moreover, the energy of the InGaP<sub>2</sub> band-to-band luminescence in sample M810 is only slightly lower than that reported for fully disordered material and indicates a low degree of partial ordering in this sample.<sup>26,29</sup>

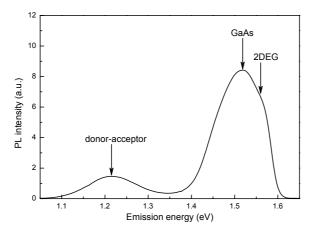


FIG. 3: GaAs PL measured at low temperature.

A more detailed graph of the GaAs photoluminescence is presented in Fig. 3. Here the sample was excited at 1.676 eV with a power density of 560 Wcm<sup>-2</sup>, comparable to that used in the up-conversion measurements discussed later. To measure the full spectrum a

silicon photodiode was used in the detection system to extend the observable range of photon energies to <1.1 eV. We observe a broad luminescence peak centred on 1.520 eV, which is consistent with reported emission energies for band edge recombination in bulk n-type GaAs.<sup>30,31</sup> We additionally observe a high-energy shoulder to this peak at about 1.560 eV, which has previously been reported as indicative of the formation of a 2DEG due to polarisation fields at the interface between GaAs and  $InGaP_2^{21,22}$  and corresponds to the region of the sample shown in the inset of Fig. 1(a), close to the rear heterojunction. At lower energies we observe a luminescence band centred on 1.214 eV, which is a common feature in n-type GaAs and can be ascribed to donor-acceptor type transitions where the acceptor level is formed by a Ga vacancy.<sup>32–34</sup> Since this luminescence band is associated with n-type material we expect it to originate from the buffer layer and/or the substrate in our sample.

#### B. Up-conversion photoluminescence measurements

Having observed evidence of partial ordering and the spatial localisation of carriers in the normal InGaP<sub>2</sub> PL, as well as an interface feature in the GaAs luminescence, we next turn our attention to up-conversion photoluminescence. In this case the laser was tuned to a photon energy of 1.720 eV, i.e. below the InGaP<sub>2</sub> band edge, such that absorption occurs in the GaAs only. The resulting PL and UPL spectra are plotted together in Fig. 4. In addition to the strong PL at the GaAs band edge we observe a broad luminescence peak at energies higher than the excitation, which we attribute to recombination of up-converted carriers in the InGaP<sub>2</sub>. This peak is centred at 1.918 eV and appears to be a combination of the two InGaP<sub>2</sub> peaks observed in the normal PL experiments.

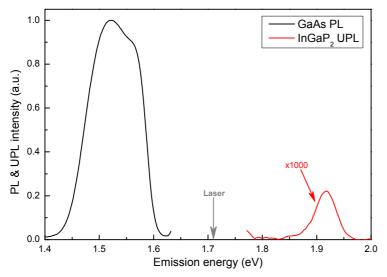


FIG. 4: Low temperature photoluminescence and up-conversion photoluminescence spectra of M810.

The InGaP<sub>2</sub> up-conversion luminescence is considerably weaker than the GaAs PL, with its peak intensity roughly 0.022 % of the GaAs. This up-conversion ratio is lower than that observed by other groups<sup>5,10</sup> and is most likely a result of the position of the GaAs/InGaP<sub>2</sub> interfaces in the sample structure. As described in section II, there are two possible interfaces where the up-conversion process can occur; the first is near the top of the sample, where the p-type InGaP<sub>2</sub> meets the p-type GaAs capping layer. Since the GaAs cap is merely 10 nm thick, only a small fraction (roughly 2 % given an absorption coefficient of 2x10<sup>4</sup> cm<sup>-1</sup> for GaAs<sup>35</sup>) of the incident light can be absorbed here, thus limiting the carrier density available for up-conversion. The second interface is in the ntype material at the rear of the InGaP<sub>2</sub>. The thick buffer layer of GaAs at this interface ensures a greater number of photogenerated carriers near the interface; i.e. in the 30-40 nm where band bending can be observed in the inset of Fig. 1(a). Hence a greater number of carriers will be available for up-conversion, leading to a higher number of upconverted photons. However, up-converted photons generated close to this interface must pass through the full thickness of the 1400 nm InGaP<sub>2</sub> layer if they are to escape the sample and reach the detection apparatus. This leaves considerable opportunity for reabsorption of the up-converted photons; we calculate that approximately 99.9 % of the up-converted emission would be reabsorbed, given an absorption coefficient of 1x10<sup>4</sup>  $\text{cm}^{-1}$  for InGaP<sub>2</sub> at a photon energy of 1.92 eV.<sup>36</sup>

#### C. Excitation spectroscopy of the GaAs PL and InGaP<sub>2</sub> UPL

In order to better understand the mechanisms responsible for the up-conversion process we performed a series of excitation spectroscopy experiments, studying the PLE spectra for both the GaAs PL and the InGaP<sub>2</sub>UPL. In the graphs of PLE and UPLE we have corrected the signal intensity to account for variations in output power of the Ti:sapphire laser at the extremes of its tuning range. However, the resulting caveat for the UPLE spectra is that the UPL signal is known to be non-linear with excitation power density.<sup>1,6,10</sup> We therefore concern ourselves primarily with trends in the data, rather than absolute figures. Shown in Fig. 5(a) are the excitation spectra for the GaAs PL, measured at three different detection energies across the peak of the GaAs luminescence. When measuring on the low energy side of the GaAs PL (at 1.476 eV, black curve) we observe a peak in the excitation spectrum close to the GaAs band edge at 1.547 eV, which is most likely related to the excitation of excitons in the GaAs. The peak exhibits a Burstein-Moss shift and appears broad, as reported elsewhere for GaAs/InGaP<sub>2</sub> samples that exhibit partial ordering of the InGaP<sub>2</sub> layer and charge accumulation in the GaAs near the heterointerface.<sup>21,37</sup> At higher excitation energies (above ~1.68 eV) we observe a quenching of the GaAs PL intensity that is common to all three detection energies across the GaAs PL and that is consistent with interface recombination loss. At these higher excitation energies the rising<sup>35</sup> absorption coefficient of GaAs means that carrier generation occurs predominantly at the interface thereby increasing the effect of nonradiative interface recombination.

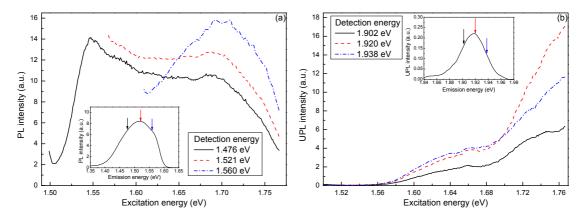


FIG. 5: Excitation spectra of (a) the GaAs PL and (b) the InGaP UPL. The excitation spectra were measured at different energies across the GaAs and  $InGaP_2$  peaks as shown in the respective insets. The PLE curves have been corrected for the intensity of the laser as a function of its emission energy.

As an aside we note also that the form of the PLE spectrum when detecting at 1.560 eV (blue curve) is different to those detected at 1.476 and 1.521 eV. The detection energy in this case coincides with the high energy shoulder of the GaAs luminescence that arises from the excitation of a 2DEG at the GaAs/InGaP<sub>2</sub> interface. At excitation energies from 1.610 to 1.690 eV we observe a steady increase in the PL intensity, whereas the intensity remains flat or exhibits a slight decrease for the two PLE spectra detected at lower energies. We ascribe this behaviour to the fact that the 2DEG is an interface phenomenon and therefore initially increases in strength as the absorption coefficient rises. This is because the reduced penetration depth of the laser at these photon energies means that a greater fraction of incident photons are absorbed close to the interface. Hence we observe increasing PL signal with increasing excitation energy, until the effect is overcome by the interface losses noted above.

Consider now the  $InGaP_2$  UPLE spectra plotted in Fig. 5(b). In contrast with some earlier reports,<sup>1,38</sup> the onset of the  $InGaP_2$  UPL in our sample occurs at around 1.560 eV,

again concurrent with the *high* energy shoulder of the GaAs PL peak and the anticipated excitation of the 2DEG. Below this photon energy no UPL signal was recorded. We therefore infer that the 2DEG present at the interface has a role to play in the up-conversion process.

As the excitation photon energy is increased further the UPL intensity in Fig. 5(b) rises to a plateau at around 1.670 eV and then rises sharply above 1.7 eV. This can be explained by the rising absorption coefficient for GaAs with increasing photon energy, which means that more carriers are generated in the region of GaAs close to the interface with the InGaP<sub>2</sub> and can contribute to the up-conversion signal. Additionally we also note that this increase in signal at high photon energies is inversely correlated (though at a different order of magnitude) with the quenching of the PLE intensity when detecting on the GaAs peak, as shown by the normalised plots in Fig. 6. This inverse correlation *may* therefore be an indicator that the up-conversion occurs predominantly at the rear interface.

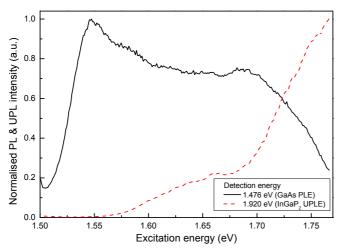


FIG. 6: Excitation spectra of the GaAs PL and InGaP<sub>2</sub> UPL (normalised for comparison of the form of the spectra).

We also note from Fig. 5(b) that for excitation energies in the range 1.58-1.70 eV the InGaP<sub>2</sub> luminescence detected at 1.938 eV exhibits the greatest intensity, while at excitation energies above 1.70 eV the InGaP<sub>2</sub> luminescence detected at 1.920 eV dominates. To explore this phenomenon further we measured the UPL spectrum at several excitation energies spanning the range of this cross-over. The resulting spectra are plotted in Fig. 7(a) and demonstrate that as the excitation energy is reduced from 1.744 to 1.590 eV the UPL peak blue-shifts by around 22 meV. We also observe a change in the shape of the UPL spectrum as the excitation energy changes. Recall, from the earlier discussion of Fig. 4, that the UPL spectrum appears to consist of the two peaks (due to

spatially localised states and band-to-band recombination) that were observed in the  $InGaP_2$  PL. It is now clear from Fig. 7(a) that the relative contribution of the peaks in the UPL changes depending upon the excitation energy.

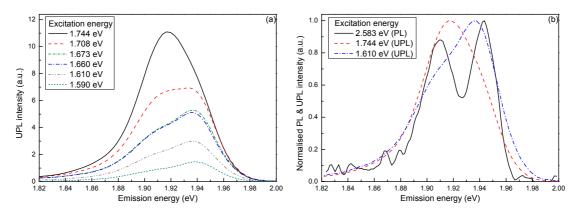


FIG. 7: Up-conversion PL spectra measured as a function of excitation energy (a). UPL spectra measured at excitation energies of 1.744 and 1.610 eV compared with normal InGaP<sub>2</sub> PL excited at 2.583 eV (b).

In Fig. 7(b) is shown a plot of the PL spectrum excited at 2.583 eV as well as two of the UPL curves from Fig. 7(a), all normalised to their maximum intensity. We observe that at an excitation energy of 1.744 eV the low energy peak (arising from the recombination of carriers that are spatially localised by partial ordering in the InGaP<sub>2</sub>) dominates the UPL spectrum, while at an excitation energy of 1.610 eV the band-to-band recombination takes over; hence the cross-over in the InGaP<sub>2</sub> UPLE spectra from Fig. 5(b). This behaviour indicates that the up-converted carriers are captured into a sub-set of the spread of spatially localised states in the InGaP<sub>2</sub> that is dependent upon the excitation energy. As the rear GaAs/InGaP<sub>2</sub> interface represents the beginning of the InGaP<sub>2</sub> growth it is reasonable to assume that the spread of localised states may vary in the direction of growth as a result of the change in growth conditions. One possible explanation therefore is that more energetic up-converted carriers (generated at higher excitation energies) may diffuse further into the InGaP<sub>2</sub> thus accessing a differing sub-set of localised states and hence shifting the peak of the UPL spectrum.

D. Dual beam up-conversion photoluminescence and excitation spectroscopy Finally we carried out a dual-beam experiment designed to enable the determination of the mechanism by which up-conversion proceeds in sample M810. We chose one beam to be of fixed energy, provided by a diode laser emitting at 1.699 eV, while the second, auxiliary beam was tuneable in order to probe the effects of excitation across the GaAs band edge. In this experiment only the diode laser was chopped and used for the lock-in detection, meaning that the tuneable auxiliary beam could provide only an additional upconversion signal when both beams were present, and *not* a separate up-conversion PL signal. The solid curve in Fig. 8(a) shows the photoluminescence spectrum recorded without the tuneable auxiliary beam – *i.e.* a 'standard' up-conversion PL spectrum. This is shown for comparison with the red curve measured when the two beams were coincident at the same spot on the sample. In this case the tuneable laser was set to a photon energy of 1.305 eV; *below* the GaAs band edge. The difference between the two up-conversion PL spectra demonstrate that the unchopped beam provided additional UPL signal, with a peak intensity roughly 10 % higher than that from the diode laser alone. We note that for the dual-beam excitation, the UPL peak was red-shifted slightly (~5 meV). This effect is most likely due to local heating of the sample arising from the additional laser excitation and fits with a small (~10 K) rise in temperature.<sup>39</sup>

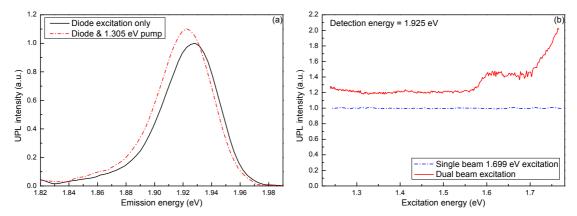


FIG. 8: Dual-beam up-conversion photoluminescence (a) and excitation spectra (b), shown with and without the second pump beam. The detection energy in (b) was 1.925 eV and the dual beam curve has been corrected for the variation in laser intensity across its tuning range, as for the previous PLE plots.

The results of the dual-beam excitation spectroscopy are plotted in Fig. 8(b), where the blue line shows the baseline; *i.e.* the UPL signal when only the fixed photon energy diode laser is present. The red curve shows the excitation spectrum measured when both beams were incident on the sample and clearly demonstrates that additional up-conversion signal was observed for all photon energies in the range of the Ti:sapphire laser from 1.240-1.771 eV.

To further explain this result we first consider the excitation energy range above the high-energy shoulder in the GaAs PL at 1.560 eV. At these high photon energies we observe an increase in the UPL signal of between 20 and 40 %, compared to single beam excitation. We stress that this increase is not related to any shift of the PL due to sample

heating. Indeed the PL red-shift arising from local heating of the sample would act to reduce the recorded intensity in the dual beam PLE experiment, since the detection energy would no longer be at the peak of the UPL. At even higher excitation energies (above  $\sim 1.7$  eV) we observe a steep rise in the additional UPL signal, which correlates well with our observation of an increase the single beam UPLE in Fig. 5(b). In the part of the spectrum where the photon energy of the tuneable auxiliary beam was below 1.560 eV we still observe additional UPL of around 20 %. Crucially, this additional UPL signal persists well below the GaAs band edge. This is a key step towards understanding the upconversion mechanism in our sample; if Auger recombination was driving the upconversion process then the second beam would only be able to provide additional upconverted light by generating additional carriers in the GaAs, *i.e.* at excitation photon energies above the GaAs band edge, or by a small boost to the efficiency of the Auger process via local heating. Since considerable additional up-conversion was observed below the energetic threshold presented by the GaAs band edge, and due to the flat spectral nature of the additional up-conversion signal, we conclude that a sequential absorption process is responsible. In the sequential absorption case additional upconversion could in principle be observed for all photon energies higher than the  $\sim 500$ meV band offset between GaAs and InGaP<sub>2</sub>, although that is beyond the range of emission energies accessible from the lasers used in this study. In fact, the lowest available excitation energy in our experiment is still above the emission energy of the donor-acceptor type impurity band luminescence observed from the GaAs. However no single beam UPL was observed at these excitation energies so it is unlikely that these states contribute to the up-conversion mechanism. Furthermore, the density of states for the impurity transitions is limited by the density of the donor impurities and Ga vacancies, spread throughout the buffer layer and substrate; not located in high density near the interface with InGaP<sub>2</sub>.

#### **IV. CONCLUSIONS**

We have demonstrated sequential two-photon absorption mediated up-conversion photoluminescence in a p-i-n  $InGaP_2$  structure grown on GaAs. Via a dual beam experiment we showed that sequential absorption is responsible for the up-conversion mechanism in our sample, since the additional up-conversion from the auxiliary beam was detected even at excitation energies below the GaAs band gap.

We observed evidence of spatial localisation in the InGaP<sub>2</sub> material in the form of distinct PL peaks in the luminescence experiments that merge into a single broad peak in the UPL. The relative contribution of these peaks to the UPL was also shown to be dependent upon the excitation energy. Excitation spectroscopy performed on the InGaP<sub>2</sub> UPL demonstrated that in our sample the UPL signal appears not at the GaAs band edge, rather at the higher energy side of the GaAs PL. This is coincident with an interface 2DEG feature in the GaAs PL, highlighting the importance of charge accumulation at the interface. Comparing the form of the GaAs PLE and the InGaP<sub>2</sub> UPLE also revealed an inverse correlation at photon energies between 1.56 and 1.76 eV. Since the quenching observed in the GaAs PLE arises from increasing interface recombination at high excitation energies, the corresponding increase in the UPLE is an indication that the up-conversion occurs predominantly at the rear heterointerface in this sample.

Our results shed new light on up-conversion processes in inorganic semiconductors and may represent a step towards harnessing this phenomenon for application in optoelectronic devices. In particular this type of photoluminescence up-conversion could in principle be harnessed in solar cells, enabling absorption and hence photocurrent from a greater portion of the solar spectrum, while maintaining an open circuit voltage derived from wider band gap material.

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#### Author contributions

NPH and TFH contributed equally to this work. NED conceived the idea and NPH, TFH and ARVS planned and conducted the experiments. All authors contributed to analysis of the results. NPH wrote the manuscript and all authors reviewed and contributed to the final version.

Data statement

Data used in the graphs presented in this paper may be provided upon request. Please contact the Experimental Solid State group in the Physics Department of Imperial College London at the following email address: exsscmthclusteroffice@imperial.ac.uk.

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